

PROCEEDINGS OF SPIE

Optical Components and Materials VIII

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Editors

25–26 January 2011
San Francisco, California, United States

Sponsored and Published by
SPIE

Volume 7934

Proceedings of SPIE, 0277-786X, v. 7934

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Author(s), "Title of Paper," in *Optical Components and Materials VIII*, edited by Michel J. F. Digonnet, Shubin Jiang, John W. Glesener, J. Christopher Dries, Proceedings of SPIE Vol. 7934 (SPIE, Bellingham, WA, 2011) Article CID Number.

ISSN 0277-786X
ISBN 9780819484710

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA
Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445
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